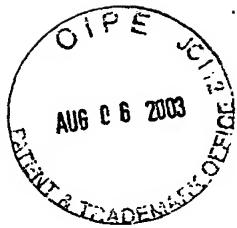


App. No. 10/604,065  
IDS Submission



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

App. No. : 10/604,065  
Applicant : Masuhiro Natsuhara et al.  
Filed : June 25, 2003  
Title : WAFER HOLDER FOR SEMICONDUCTOR  
MANUFACTURING DEVICE AND SEMICONDUCTOR  
MANUFACTURING DEVICE IN WHICH IT IS  
INSTALLED  
Tech. Cntr./Art Unit : (to be assigned)  
Examiner : (to be assigned)  
Docket No. : 39.015-AG

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

### INFORMATION DISCLOSURE STATEMENT

Sir:

This constitutes an Information Disclosure Statement pursuant to 37 C.F.R. §§ 1.97 and 1.98. The attached documents as listed on the accompanying Form PTO/SB/08A are hereby brought to the Examiner's attention in the patent application identified above. A copy of this form accompanies this paper.

### Concise Explanation of the Relevance/Copy of Translation Pursuant to 37 C.F.R. § 1.98(a)(3)(i)&(ii)

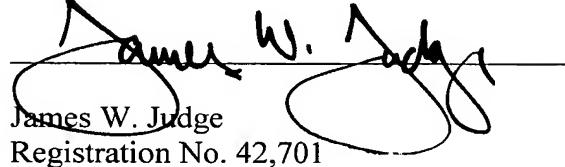
Abstracts in English, prepared by Patent Abstracts of Japan, of non-English references JP H04-78138 and JP H13-118664 are readily available to the applicant through the Japanese Patent Office Web site, and are attached to the respective fronts of these Japanese documents.

A concise explanation of the relevance of Japanese references JP H04-78138 and JP 2001-118664 is incorporated into the specification in the present application, in paragraphs 0005 and 0006 respectively. Furthermore, machine-translated abstracts thereof, available through the Japanese Patent Office Web site, are attached to the front of each reference.

The Examiner is respectfully requested to consider these references, and to indicate so on the accompanying Form PTO/SB/08A and make the document of record in the present application.

Respectfully submitted,

July 30, 2003



James W. Judge  
Registration No. 42,701

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PTO/SB/08A (10-01)

Approved for use through 10/31/2002. OMB 0651-0031

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Substitute for form 1449A/PTO				<b>Complete if Known</b>	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(use as many sheets as necessary)</i>				Application Number	10/604,065
				Filing Date	June 25, 2003
				First Named Inventor	Masuhiro Natsuhara
				Art Unit	(to be assigned)
				Examiner Name	(to be assigned)
Sheet	1	of	1	Attorney Docket Number	
39.015-AG					

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. 1	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code <sup>3</sup> -Number <sup>4</sup> - Kind Code <sup>5</sup> (if known)			
		JP-H04-78138-A JP-2001-118664	03-12-1992 04-27-2001	NGK INSULATORS LTD IBIDEN CO LTD	

Examiner Signature		Date Considered	
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**\*EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. 3 Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.

Original language translation is attached.

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